

<b>Notice of References Cited</b>	Application/Control No. 10/675,879	Applicant(s)/Patent Under Reexamination LIU, CHANGWEN	
	Examiner Gary Mui	Art Unit 2616	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,937,591	08-2005	Guo et al.	370/338
*	B	US-6,285,662	09-2001	Watanabe et al.	370/280
*	C	US-7,027,462	04-2006	Benveniste, Mathilde	370/447
*	D	US-7,085,284	08-2006	Negus, Kevin	370/461
*	E	US-2001/0055312	12-2001	Negus, Kevin J.	370/445
*	F	US-2002/0071448	06-2002	Cervello et al.	370/445
*	G	US-2004/0004973	01-2004	Lee, Jae-Ho	370/445
*	H	US-2004/0136396	07-2004	Yonge et al.	370/445
*	I	US-2004/0264423	12-2004	Ginzburg et al.	370/338
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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